IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Customer Number: 89518

Hui-Mei Chen, et al. Confirmation Number: 3341

Application No.: 10/786,807 Group Art Unit: 2822

Filed: February 25, 2004 Examiner: Bac H. Au

For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

TRANSMITTAL

Mail Stop RCE Commissioner for Patents P.O. Box 1450

Dear Sir:

Alexandria, VA 22313-1450

CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being electronically-transmitted to the United States Patent and Trademark Office on July 12, 2010. /Tobi A. Herbert/

Tobi A. Herbert

Extension of Time, in the above-identified application.

Also attached: Change to Large Ferting Co. Transmitted herewith is a Request for Continued Examination and an Amendment, including a Petition for One-Month

The fee has been calculated as shown below:					
	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	8	20	0	\$52.00 =	\$0.00
Independent Claims	3	3	0	\$220.00 =	\$0.00
Fee for extension of time				\$130.00	
		Request for Continued Examination (RCE)			\$810.00
		Total of Above Calculations			\$940.00

 \boxtimes Please charge my Deposit Account No. 502624 in the amount of \$940.00.

 \boxtimes The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 502624, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

/Dennis A. Duchene/ Dennis A. Duchene Registration No. 40,595

11682 El Camino Real, Suite 400 San Diego, CA 92130 Phone: 858,720,3300 DAD:msm Facsimile: 858.720.7800 Date: July 12, 2010

Please recognize our Customer No. 89518 as our correspondence address.